



INSTITUT DE CHIMIE
SEPARATIVE DE MARCOULE



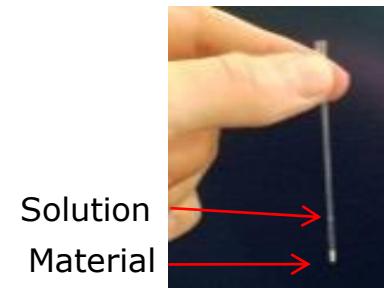
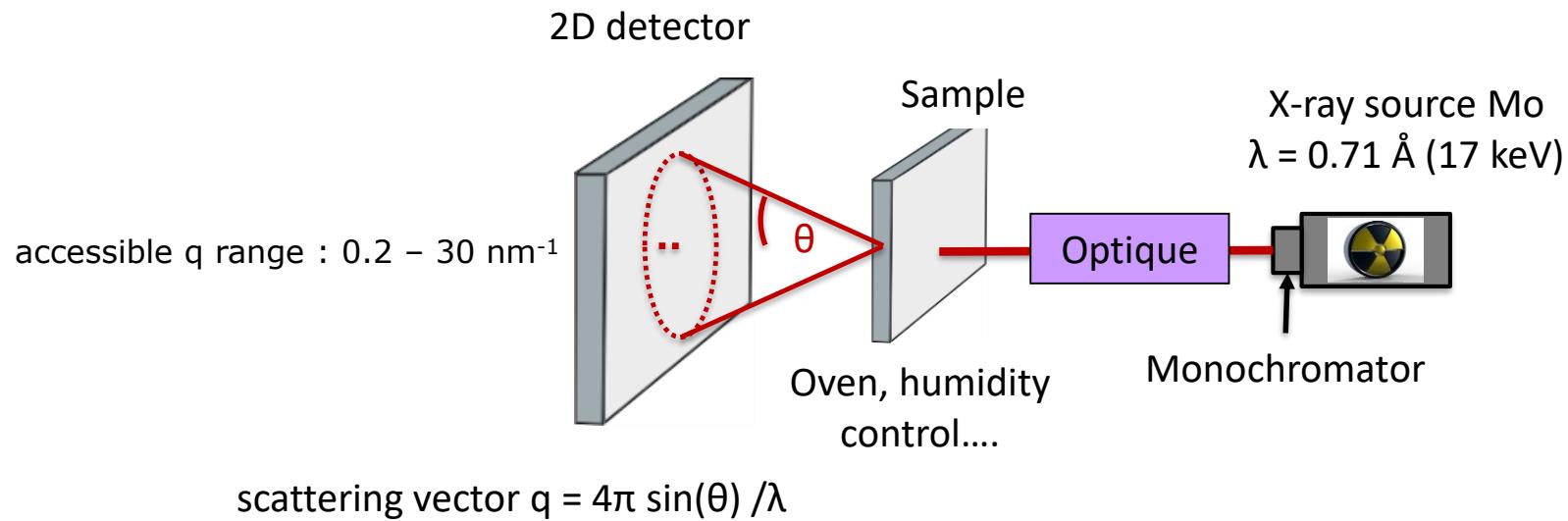
Introduction to the study of surface by Small Angle X-ray Scattering



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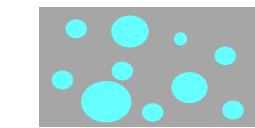
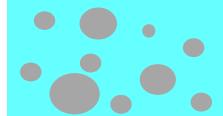
SAXS



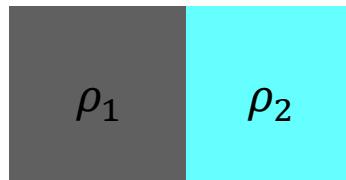
Absolute intensity

$$I_{abs}(q) = \frac{N}{V_{probed}} \cdot \Delta\rho^2 \cdot V_{obj}^2 \cdot P(q) \cdot S(q)$$

Density of object in
the probed volume



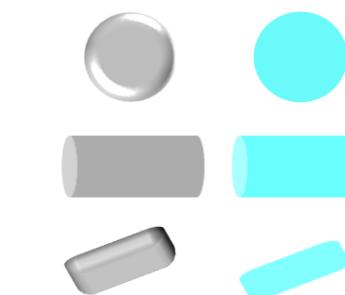
Scattering lenght
density contrast



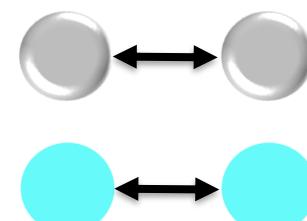
Object volume



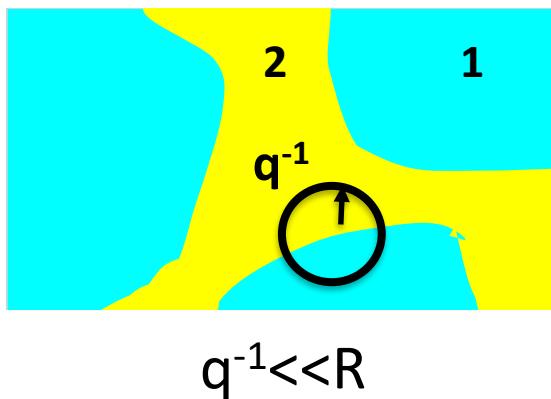
Form factor



Structure factor



Porod's law



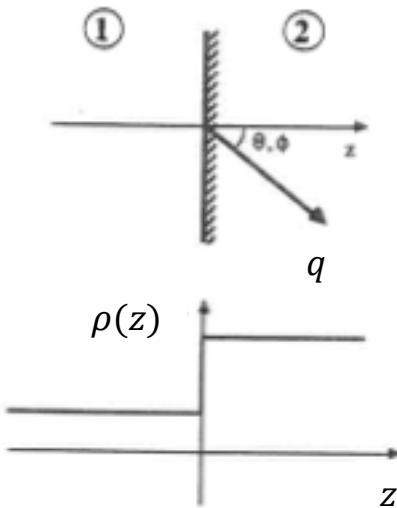
If $q \gg$ curvature \rightarrow flat at q^{-1} scale \rightarrow **Porod's Regime**

$$d = 2\pi/q \quad \text{Porod's law}$$

$$I(q) = 2\pi(\rho_1 - \rho_2)^2 \Sigma \frac{1}{q^4}$$



Total interfacial area per unit volume (S/V)



Thus Porod's law traduces the reflection of the incident beam on the portions of interface in the samples which have the right orientation to yield a reflected beam at a given scattering angle. In this sense, Porod's law is nothing else than Fresnel's law of reflectivity calculated in the Born approximation, a point of view particularly developed in ref. [7].

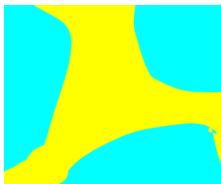


Porod's law deviation

Porod's law

$$I(q) = 2\pi(\rho_1 - \rho_2)^2 \Sigma \frac{1}{q^4}$$

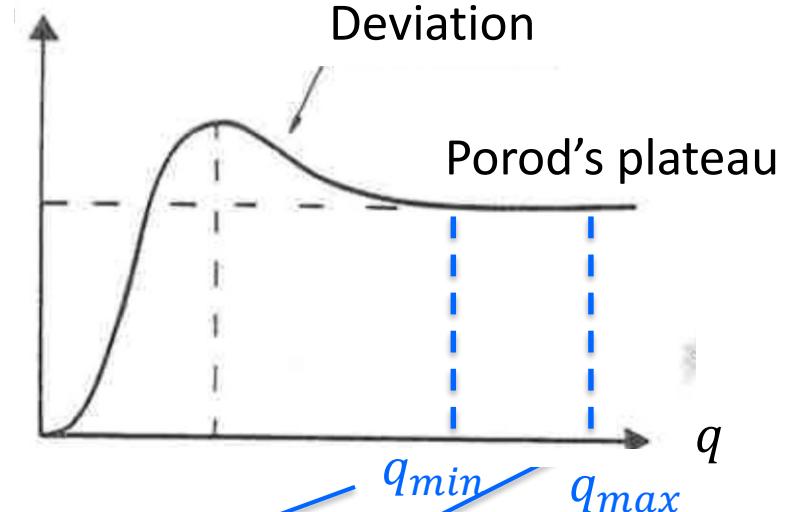
Courvature
Roughness
Fractality



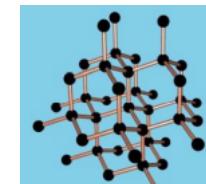
$$d_{max} = \frac{\pi}{q_{min}}$$



$$I(q) \cdot q^4$$

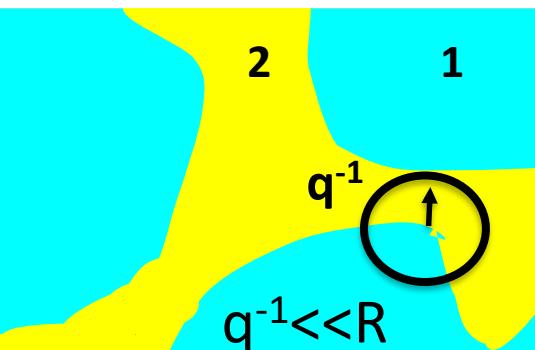


$$d_{min} = \frac{\pi}{q_{max}}$$



Atomic scattering
(crystallography)

Effect of curvature



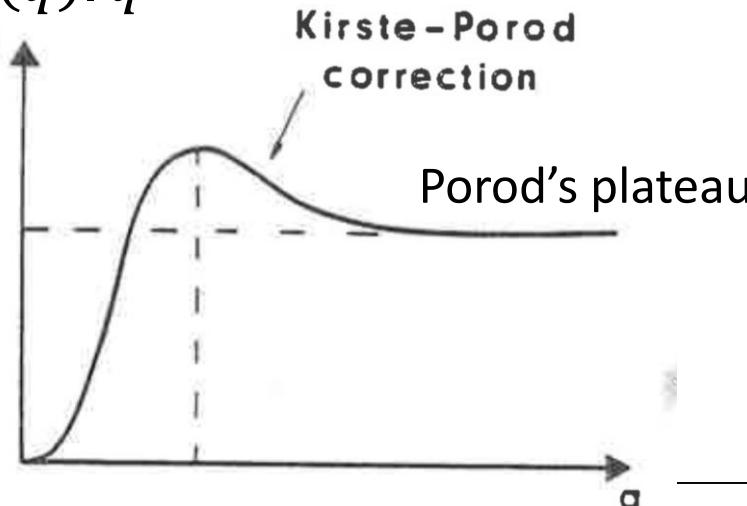
$q^{-1} \equiv$ Interface curvature

Kirste-Porod Formula => addition of q^{-6} term

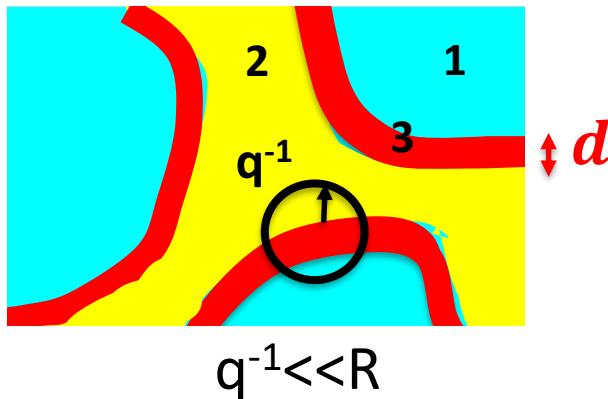
$$I(q) = 2\pi(\rho_1 - \rho_2)^2 \Sigma \frac{1}{q^4} \left(1 + \frac{1}{q^2} \left[\frac{1}{4} \langle (C_1 + C_2)^2 \rangle + \frac{1}{8} \langle (C_1 - C_2)^2 \rangle \right] \right)$$

Local principal surface curvature

$$I(q) \cdot q^4$$



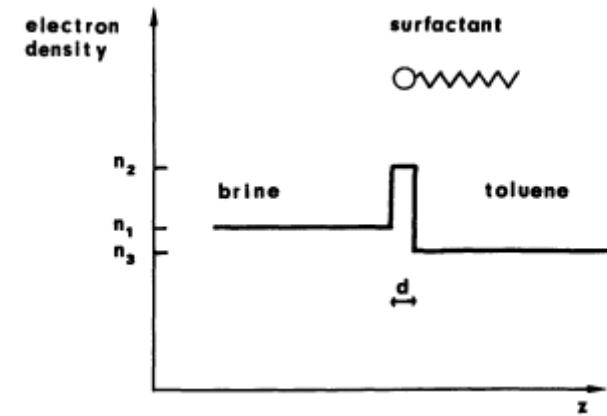
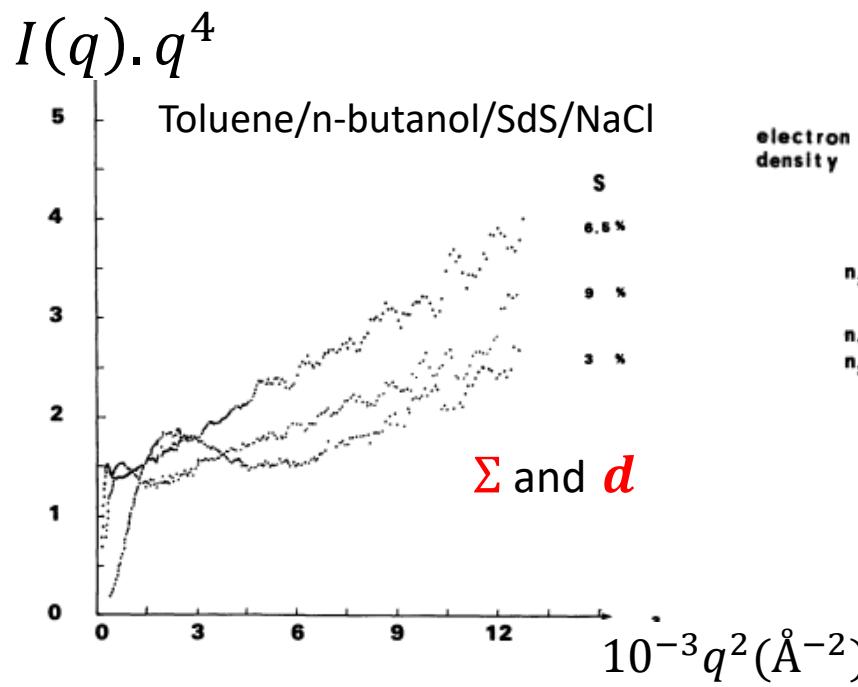
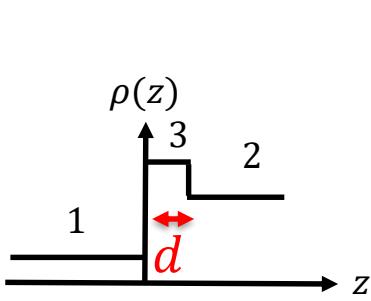
When the interface is grafted or covered



$$\lim_{qd \ll 1} I(q) q^4$$

$$= 2\pi\Sigma(\rho_2 - \rho_1)^2 \cdot (1 + \frac{(\rho_3 - \rho_1)(\rho_3 - \rho_2)}{(\rho_2 - \rho_1)^2} (qd)^2 + \epsilon(qd)^4)$$

Scattering of disk



=> amount of surfactant grafted per nm^2 of surface

L. Auvray et al , Microemulsions: a small angle X-ray scattering study. Journal de Physique, 1984, 45 (5), pp.913-928.

L. Auvray, J.P. Cotton, R. Ober, C. Taupin, Structure of concentrated Windsor microemulsion by SANS, Physica 136B (1986) 281-283.



Diffuse interface

negative deviations from the Porod law due to the diffuse interface



$$\lim_{q \rightarrow \infty} [I(q)] = I_p(q)H^2(q) + I_{FI}(q)$$

Density fluctuation
within the diffuse layer

$$I_{FIcor} = I_p(q)H^2(q)$$

$$K_p = 2\pi\Sigma(\Delta\rho)^2$$

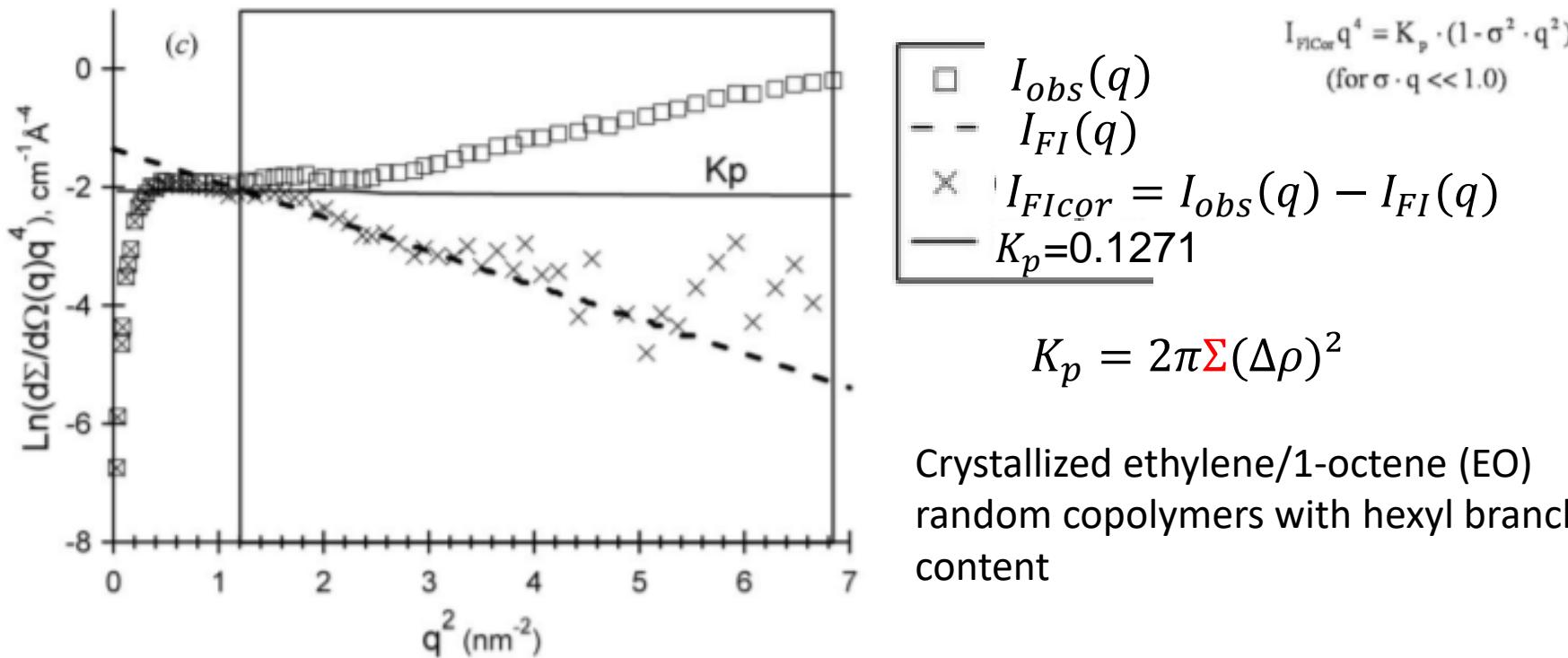
K_p = Porod constant

Smoothing (Ghost) Function, $h(r)$			
Expected Electron Density Profile, $\tilde{n}(r) = g(r) * h(r)$			
<u>Modified Porod's Law</u>			
- exact	$I_{FIcor} q^4 = K_p \frac{\sin^2(E \cdot q/2)}{(E \cdot q/2)^2}$	$I_{FIcor} q^4 = K_p \left[\frac{4 \sin(T \cdot q/4)}{(T \cdot q)} \right]$	
- expanded	$I_{FIcor} q^4 = K_p \left(1 - \frac{E^2 \cdot q^2}{12} \right)$ (for $E \cdot q/2 \ll 1.0$)	$I_{FIcor} q^4 = K_p \left(1 - \frac{T^2 \cdot q^2}{24} \right)$ (for $T \cdot q/4 \ll 1.0$)	$I_{FIcor} q^4 = K_p \cdot (1 - \sigma^2 \cdot q^2)$
<u>Required Plot</u>			
- exact	-	$\ln(I_{FIcor} q^4) \text{ vs. } q^2$	
- expanded	$I_{FIcor} q^4 \text{ vs. } q^2$	$I_{FIcor} q^4 \text{ vs. } q^2$	$I_{FIcor} q^4 \text{ vs. } q^2$
<u>Determination of</u>	<u>transition layer thickness, E and T</u>	<u>standard deviation, σ</u>	
- exact	-	$\sigma = \sqrt{-m}$	
- expanded ^{a)}	$E = \sqrt{\frac{-12 \cdot m}{K_p}}$	$\sigma = \sqrt{m/K_p}$	
	$T = 2\sqrt{\frac{-6 \cdot m}{K_p}}$		
Relationship	$T (= 2\sqrt{6}\sigma) > E (= \sqrt{12}\sigma) > \sigma$		
References	Vonk (1973)	this work	Ruland (1971)
(a) K_p and m are Porod's constant (see the text for definition) and slope in each plot.			

Diffuse interface

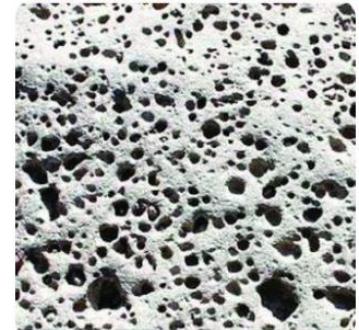
Modified Porod's law plot for sigmoidal (σ model) gradient

$$I_{\text{FlCor}} q^4 = K_p \cdot \exp(-\sigma^2 \cdot q^2)$$



Fully random dispersion of 2 phases at any scale

=> Debye Model



$$I(q) \sim \frac{1}{(1 + q^2 l_p^2)^2}$$

$$l_p \Sigma = 4\Phi(1-\Phi)$$

Porod's lenght

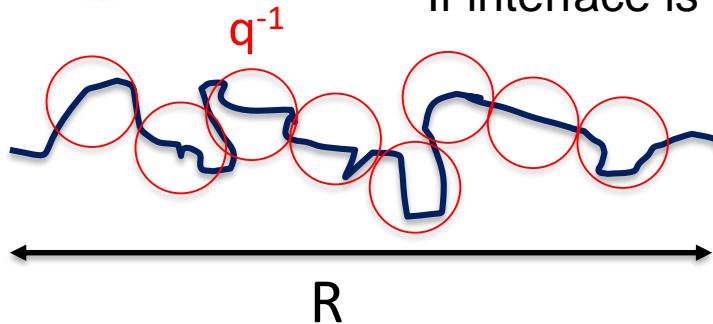
Volume fraction
of one phase

- ⌚ $I(q)q^4$ => monotonously increasing + no asymptotic behavior
- ⌚ Not satisfying for smooth surfaces
- ⌚ Not realistic since it assumes a too broad of pore sizes



Rough interface

If interface is rough => its area depends on the scale of observation



Number of blob

$$I(q) \sim N_s(q^{-1}) \cdot g_s^2 \cdot (q^{-1})$$

Number of scattering element in one blob

Because the scattering element occupied a fraction of the blob volume $\sim q^{-d}$

$N_s \Rightarrow$ depends on the roughness

$$g_s \sim \left(\frac{q^{-1}}{a}\right)^d$$

size of the scattering element

$$\sum (q^{-1}) \sim N_s(q^{-1})(q^{-1})^{d-1}$$

Apparent area seen at the resolution q^{-1}

$$I(q) \sim N_s g_s^2 \sim \frac{\Sigma(q^{-1})}{a^{2d} q^{d+1}}$$

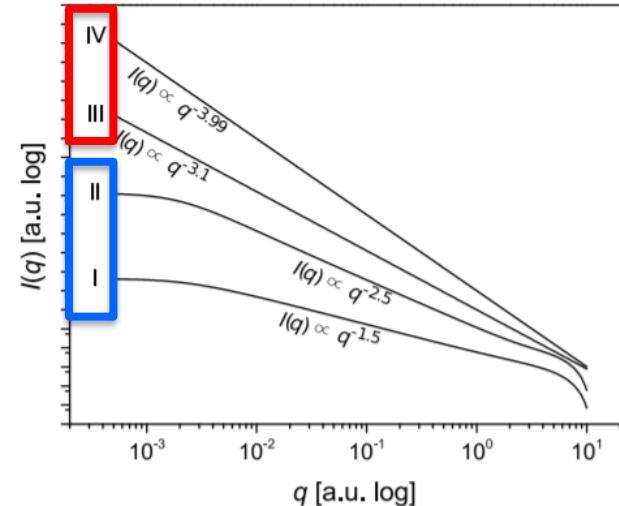
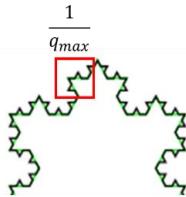
Ex: For d=3
Porod's law

$$I(q) \sim \frac{\Sigma(q^{-1})}{a^6 q^4}$$



Fractal structures

$$I(q) \propto q^{-D}$$



Surface fractal

Diffusion from surfaces

$$I(q) \propto q^{D_s - 6}$$

$$3 < 6 - D_s < 4$$

$$I(q) = A \frac{\Gamma(5 - D_s) \sin[\pi(3 - D_s)/2]}{(3 - D_s)} q^{D_s - 6}$$

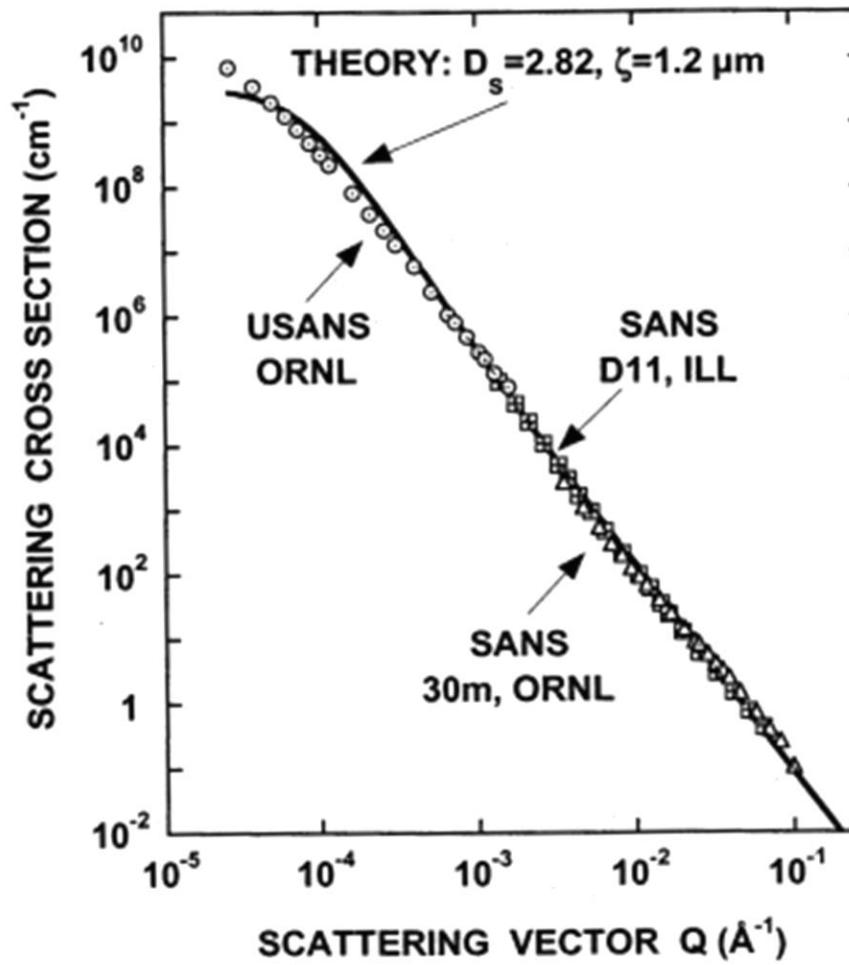
$$\Sigma(R) = \Sigma_x R^{2 - D_s}$$

$D < 3$ Diffusion from volume

Length scale
 $R = 4 \text{ \AA}$ for N_2

More complicated

Several instruments to cover a large q range

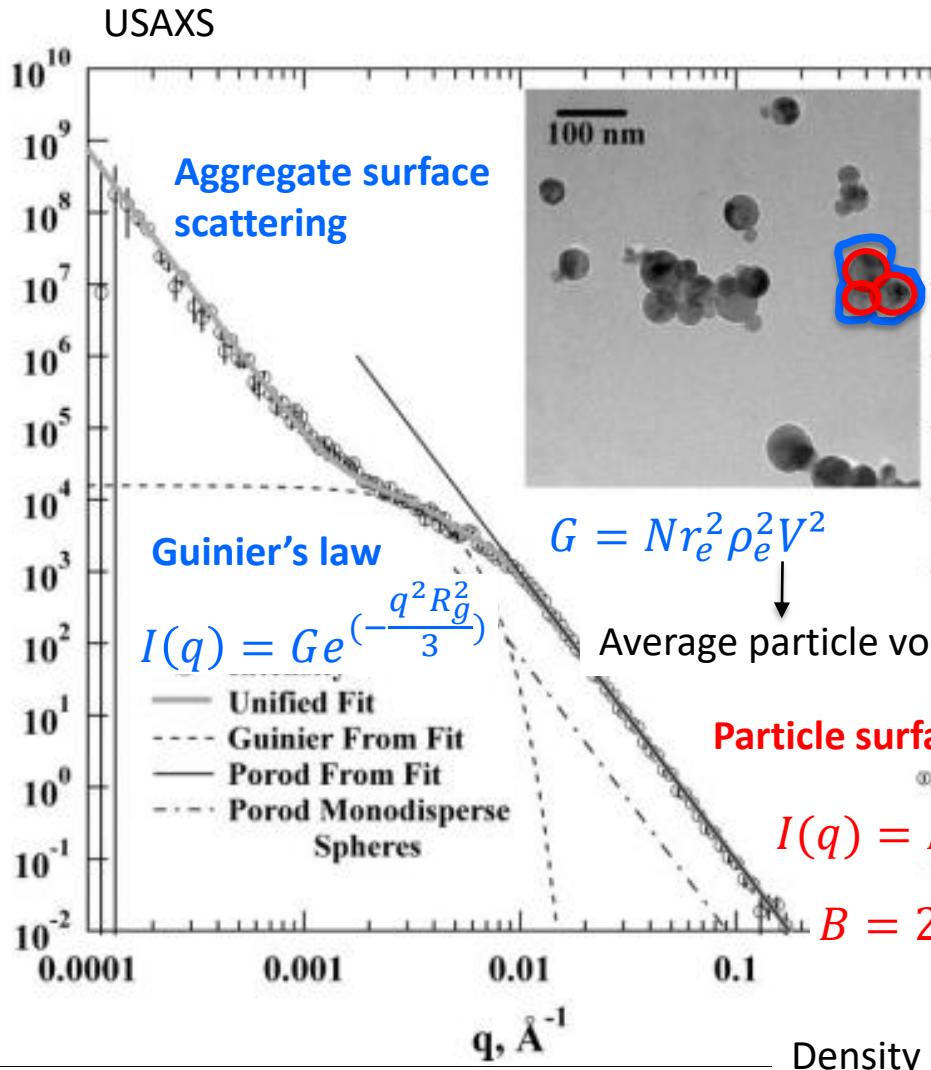


sedimentary rock



Generalization to packing of polydisperse particles

Spherical primary particles



Global unified scattering function

$$I(q) = Ge^{(-\frac{q^2 R_g^2}{3})} + B(q^*)^{-4}$$

$$q^* = \frac{q}{\left[\operatorname{erf}\left(\frac{qR_g}{\sqrt{6}} \right) \right]^3}$$

Monodisperse spheres $I(R, q) = \frac{1.62G}{R_g^4} q^{-4}$

Polydisperse spheres $\frac{\pi B}{Q} = \Sigma$

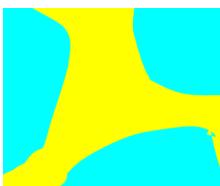
Summary

Porod's law

$$I(q) = 2\pi(\rho_1 - \rho_2)^2 \Sigma \frac{1}{q^4}$$

Total interfacial area
per unit volume

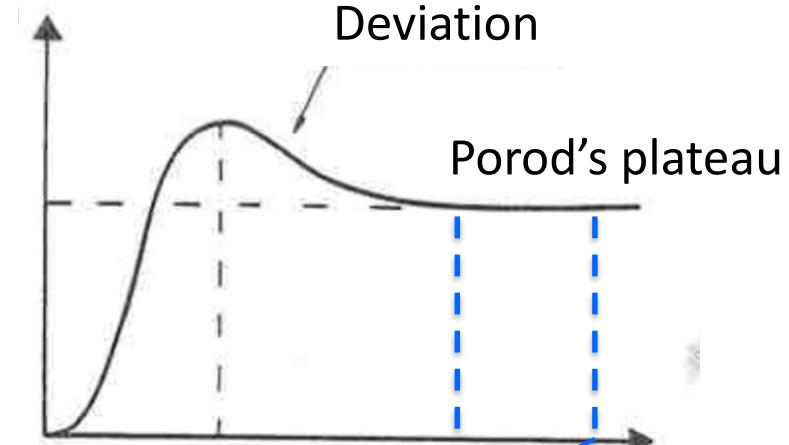
Courvature
Roughness
Fractality



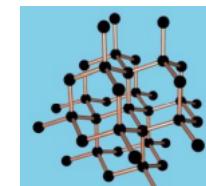
$$d_{max} = \frac{\pi}{q_{min}}$$



$$I(q) \cdot q^4$$



$$q_{min} \quad q_{max}$$



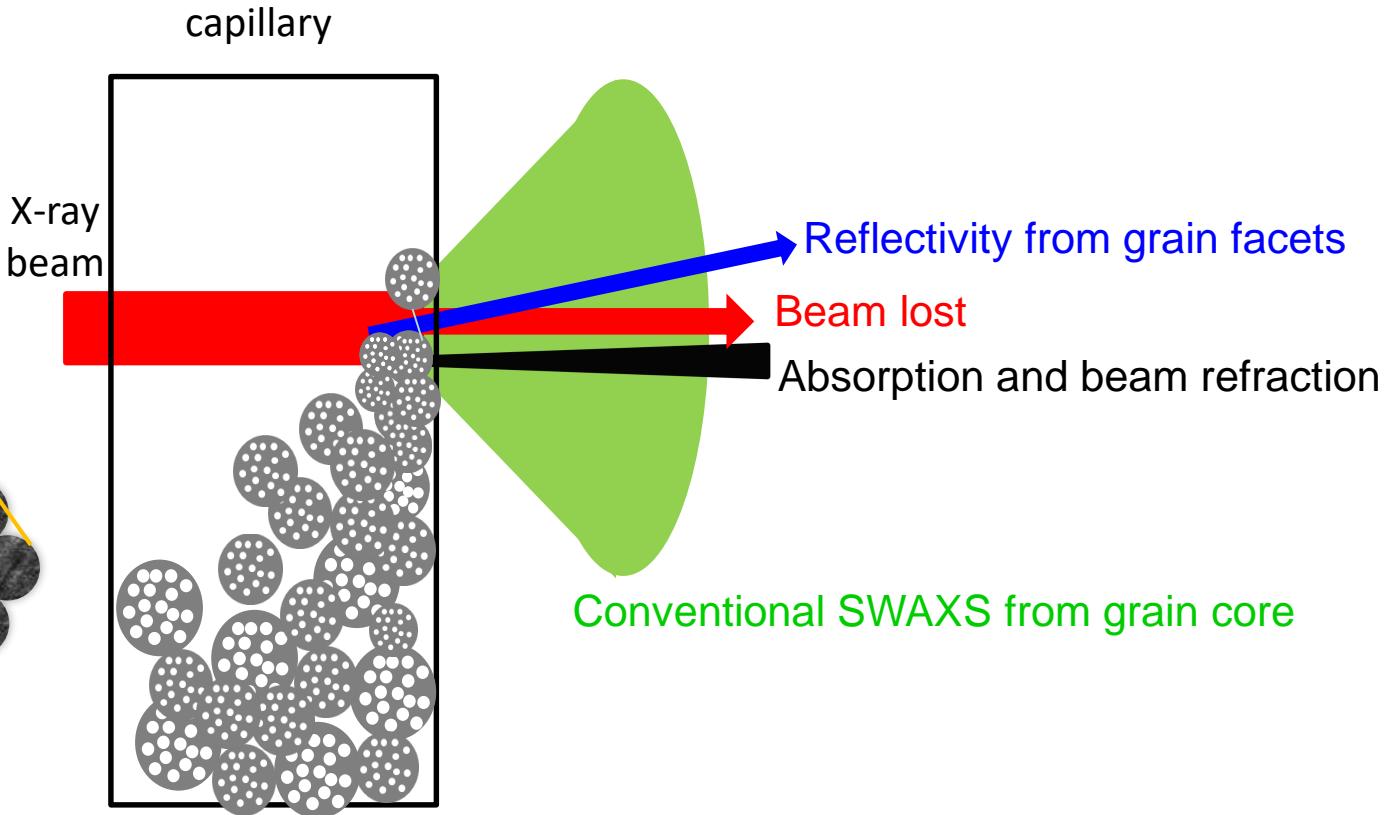
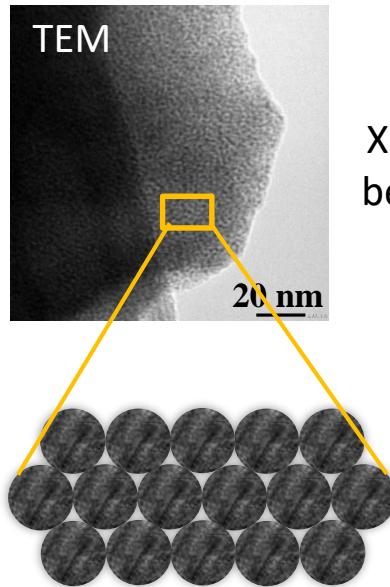
$$d_{min} = \frac{\pi}{q_{max}}$$

Atomic scattering
(crystallography)

Highly absorbing materials

UO_2 or $\text{ThO}_2 \Rightarrow$ Absorption length $\approx 10 \mu\text{m}$ (17.4 keV)

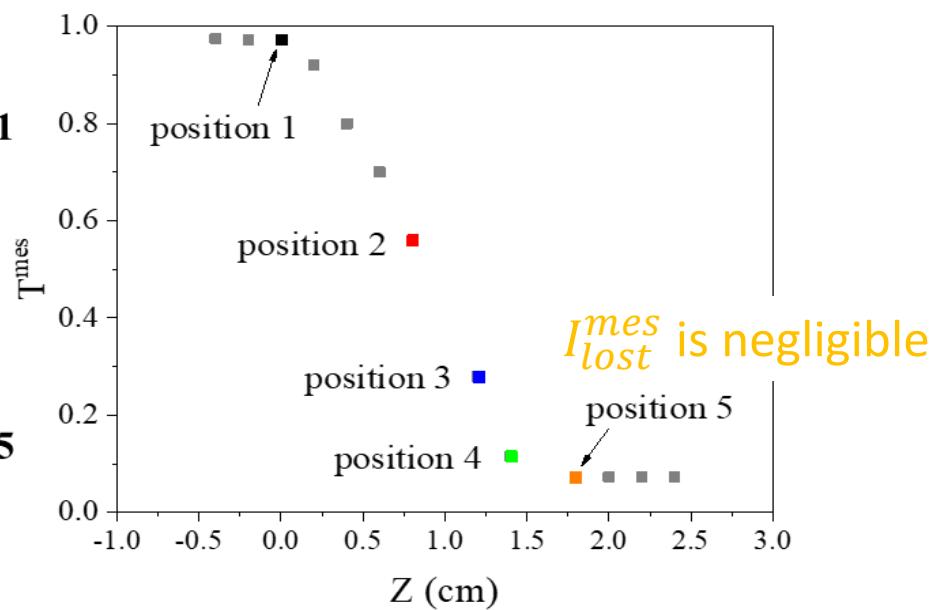
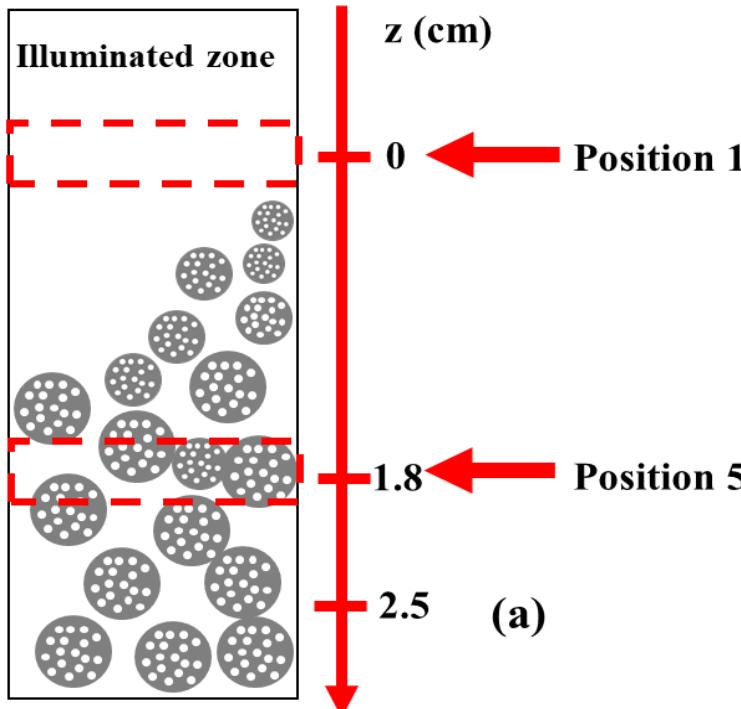
loose packing of ThO_2
nanoparticles



Highly absorbing materials

How to obtain the I_{abs} with the right transmission?

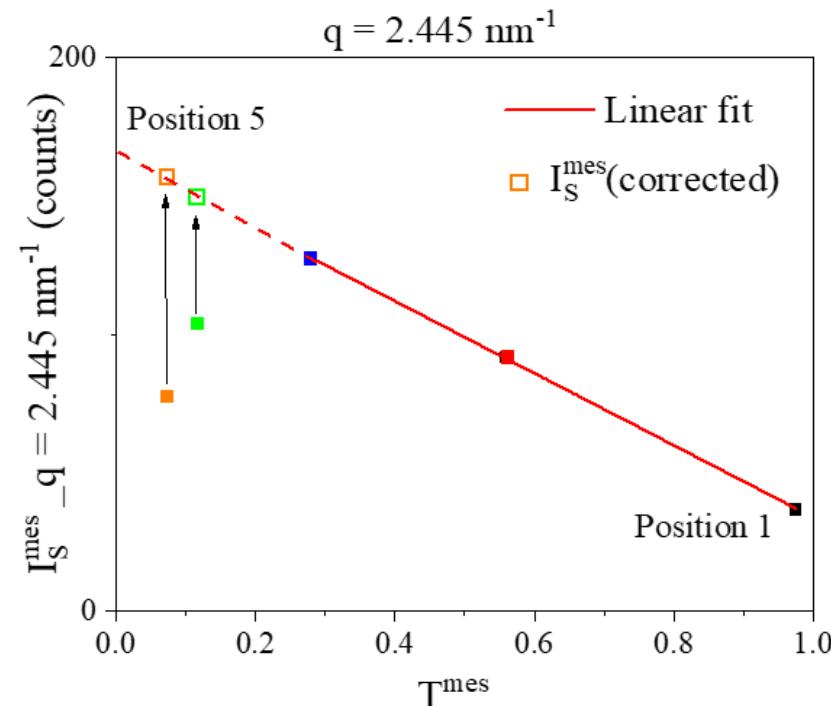
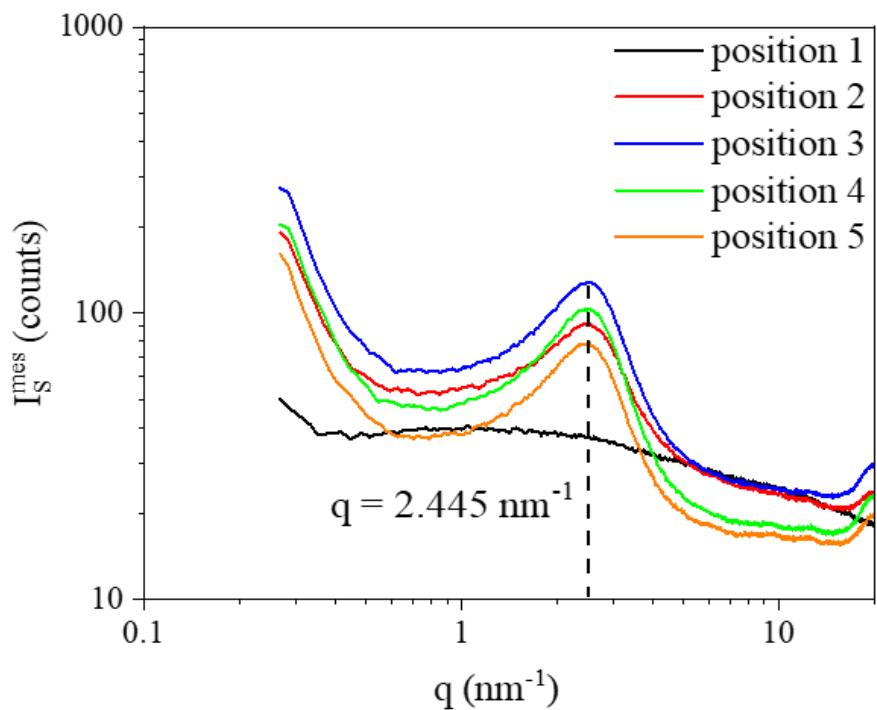
1. Measured transmission T^{mes} as a function of the vertical distance z from the interface powder/air



Highly absorbing materials

How to obtain the I_{S}^{abs} with the right transmission

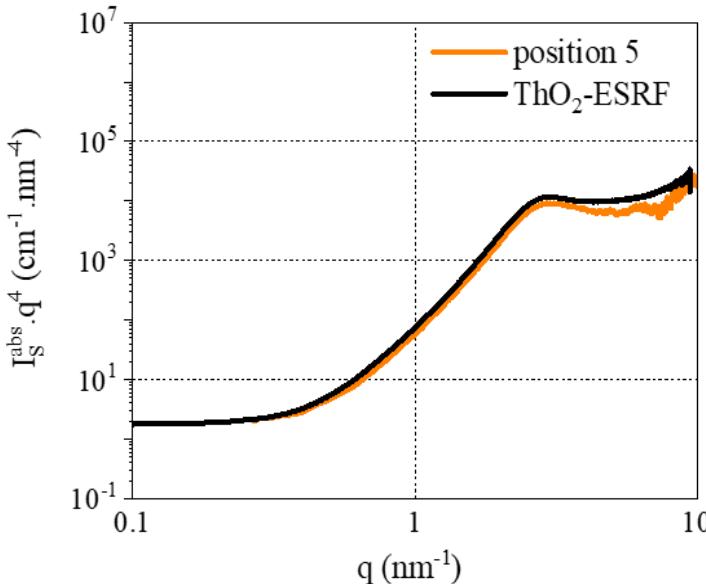
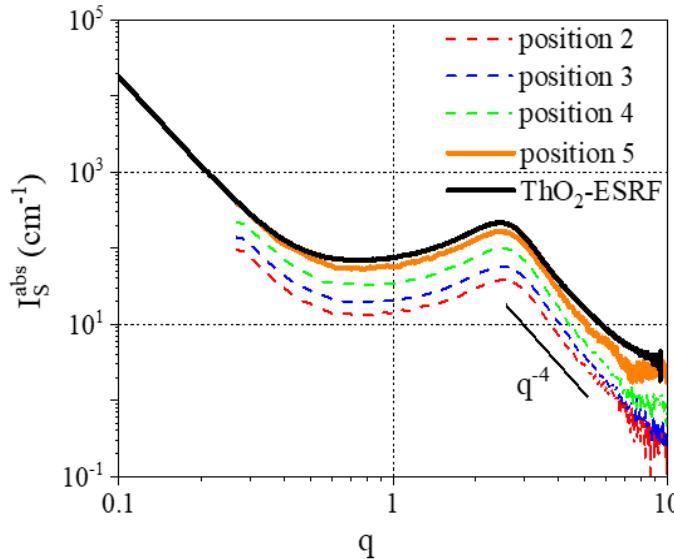
2. I_S^{mes} has to be corrected from the multi-scattering and indirect absorption effects occurring in low transmission case





Highly absorbing materials

How to obtain the $I_{S\text{abs}}$ with the right transmission



$$I_S^{\text{abs}} = \frac{1}{J_{in} A \epsilon \Delta \Omega e_b} \left(\frac{\alpha I_S^{\text{mes}}(\text{sample}) - I_B}{t_{\text{sample}} T_{\text{sample}}^{\text{mes}}} - \frac{I_S^{\text{mes}}(\text{tube}) - I_B}{t_{\text{tube}} T_{\text{tube}}^{\text{mes}}} \right)$$

$$\frac{S}{V} = \frac{\lim_{q \rightarrow \infty} I_S^{\text{abs}} q^4}{2\pi \Delta SLD^2}$$

ESRF (16 keV) => lower absorption and smaller beam size

position	S (m ² /g)	Porosity ϕ
2	60	0.08
3	80	0.11
4	127	0.19
5	284	0.34
ESRF	310	0.45